



Indian Institute of Technology Kharagpur

CENTRAL RESEARCH FACILITY

Dual/Cross Beam FIB-FEG Microscopy Laboratory

(FIB Lab, GF-03, New Building, New CRF)

APPLICATION FORM FOR USER

Date: _____

I, _____, From Academic Institute or R&D. Industry, Name _____, Department / Center Name _____, would like to get slot on EBSD (Data acquisition) / FIB Lithography / TEM Lamella Preparation facility on this instrument. Kindly allot me _____ no. of slot(s) for the above facility. Transaction id is _____, GST No. (If any) _____.

** TERMS & CONDITIONS FOR AVAILING INSTRUMENT FACILITIES

1. For the time slot and other necessary criteria, please contact the concerned staff beforehand
2. Repeat of analysis may be done if there is any instrumental or operating error.
3. Acknowledge the CRF Facility in the future publication.
4. The charges should be paid in advance by online fund transfer to below account details. Transferred amount will not be reversible.
6. Kindly attach screen shot of transaction details after successful transaction with hard copy of these form. The receipt will be mail to user's given address.
7. The transferred amount is not refundable by any case.

Charges for every facility are given below (GST Included)-

1. EBSD(3Hrs.) – Charge per slot for Academic Institute or R&D. is 4,130₹ (3500+18%) and 5,782₹ (4900+18%) for Industry.
2. FIB Lithography(3Hrs.) – Charge per slot for Academic Institute or R&D. is 5,782₹ (4900+18%) and 7,434₹ (6300+18%) for Industry.
3. TEM Lamella Prep. (3-5 Hrs.)– Charge per slot for Academic Institute or R&D. is 7,434₹ (6300+18%) and 9,086₹(7700+18%) for Industry.

Full Address-Name: _____

Mobile No.: _____ Pin: _____

Signature of the user

Supervisor Name: _____

Department: _____

Institute: _____